

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:**

Wood et al.

**Serial No.:** 10/666,742

**Filed:** September 19, 2003

**For:** METHODS FOR THINNING  
SEMICONDUCTOR SUBSTRATES THAT  
EMPLOY SUPPORT STRUCTURES  
FORMED ON THE SUBSTRATES  
(Amended)

**Confirmation No.:** 6057

**Examiner:** A. Ghyka

**Group Art Unit:** 2812

**Attorney Docket No.:** 2269-6095US  
(03-0593.00/US)

**VIA ELECTRONIC FILING**  
**December 7, 2007**

**RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This Response follows the final Office Action of October 10, 2007, the shortened statutory period for response to which expires on January 10, 2008. This Response is being submitted within two months of the mailing date of the final Office Action.